



IFW

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In re Patent Application of: Alex Salnik et al.

Atty Docket No. TWI-24910

Application No.: 10/796,603

Filed: March 8, 2004

Confirmation No.: 1794

For: CHARACTERIZATION OF ULTRA SHALLOW JUNCTIONS IN SEMICONDUCTOR WAFERS

M/S AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

| | CLAIMS REMAINING AFTER AMENDMENT | | HIGHEST NO. PREVIOUSLY PAID FOR | PRESENT EXTRA | RATE | ADDITIONAL FEE |
|---|---|-------|---------------------------------------|------------------|-----------|-------------------|
| TOTAL | 17 | MINUS | 21 | 0 | x \$50 = | \$0 |
| INDEP. | 7 | MINUS | 7 | 0 | x \$200 = | \$0 |
| FIRST PRESENTATION OF MULTIPLE DEP CLAIMS | | | | | + \$360 | \$0 |
| TOTAL | | | | | | \$0 |

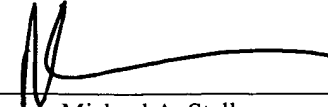
Small Entity 50% Filing Fee Reduction (if applicable) \$0

- * If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
- ** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
- *** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent) is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

1. ☒ No additional fee is required.
2. ☒ Attached for filing is a Replacement Sheet of formal drawings representing Figs. 2 and 3.
3. ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. TWI-24910.
A duplicate copy of this sheet is enclosed.
4. ☒ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

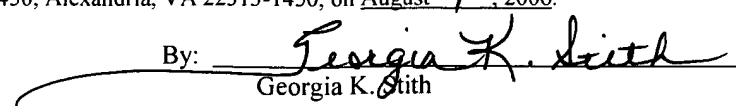
Dated: August 7, 2006

By: 
Michael A. Stallman (Reg. No. 29,444)
Attorneys for Applicant(s)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 7, 2006.

Dated: August 7, 2006

By: 
Georgia K. Stith

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Group Art Unit: 2877

Examiner: Michael A. Lyons

**RESPONSE TO OFFICE ACTION
MAILED JUNE 1, 2006**353 Sacramento Street, Suite 2200
San Francisco, CA 94111
Telephone: (415) 772-4900
Facsimile: (415) 398-2890M/S AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited
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Box 1450, Alexandria, VA 22313-1450 on August 7, 2006.

STALLMAN & POLLOCK LLP

Dated: 08/7/2006

By:

Georgia K. Stith

Sir:

In response to the Office Action dated June 1, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include an attached replacement sheet.

Remarks begin on page 8 of this paper.